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EFFECT OF ETCHING TIME OF PS ON THE EFFICIENY OF CLALPC/PS DSSC

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ABSTRACT: The nanostructured porous silicon (PS) samples were prepared by electrochemical anodic dissolution of doped silicon (p-Si) for (100) orientations at constant current density of 30mA/cm² for etching times 10, 20, 40 and 60 min. Then these samples were sensitized with chloroaluminium phthalocyanine (ClAlPc) to fabricate Dye-sensitized solar cells (DSSCs). The diffuse reflection spectra (DRS) curves of sensitized porous silicon (ClAlPc/PS) had a wide absorption range of 450-750 nm, due to ClAlPc as a sensitizer in PS. The bandgap measurements from UV- Vis and photoluminescence measurements are in the range of 1.5 to 1.8 eV. The photocurrent and photovoltage of the cells were measured with an active area of 1 cm² using Keithely source meter in the condition of illumination (80 mW cm⁻²). The open circuit voltage (Voc), short circuit current (Jsc) and fill factor (FF) of the DSSC were calculated and analyzed. The sensitized sample prepared at 30mA/cm² for etching time 60 min with 48% of HF shows better conversion efficiency of 2.8 %.

Keywords: [Porous silicon; HF concentration; DSSCs.]

1. INTRODUCTION

In recent years, dye-sensitized solar cells (DSSCs) are attracting widespread academic and commercial attention for the conversion of sunlight into electricity because of their low cost and high efficiency [1]. Porous silicon (PS), a nanostructured material, has attracted considerable attention as a measure to enhance the optical properties of silicon (Si). The formation of PS layers on crystalline Si (c-Si) wafers using electrochemical etching (ECE) exhibits photoluminescent and electroluminescent properties similar to those of semiconductors with direct energy gap [2]. A highly porous PS layer can enhance the efficiency of solar cells by increasing light trapping into the active

region [3]. The chloroaluminum phthalocyanine (ClAlPc) compound and some of its derivatives display a number of interesting characteristics among pigments[4]. Due to high photoactivity and charge generation efficiency in addition to a strong absorbance in the visible range, the films of these complexes could be used as active layers in solar cells and organic electronics devices [5-10]. To improve the device performance various nonplanar phthalocyanine materials electron donors used as in organic photovoltaics have been reported [11-12]. The ClAlPc which is the halogenated derivative of Pc having more solubility (0.001M) on which much works is not reported to the best of our knowledge. In this work, we demonstrate the

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use of porous silicon (P-Si) as photoanode in DSSCs with platinum as counter electrodes. Here we used, The ClAlPc as a sensitizer.

2. EXPERIMENTAL

Samples used in this study are boron doped crystalline Silicon (c-Si) wafers (thickness 517 µm and resistivity 0.2- 0.5 cm) grown by Czochralski (CZ) method in (100). The porous samples were prepared by electrochemical anodic dissolution of doped silicon (p-Si) in various concentrations of hydrofluoric acid, H2O and ethanol with platinum electrode as cathode. The electrolyte was prepared by mixing HF, H2O and ethanol in 1:1:2 ratios. The porous layers on the surface of these samples (p-type c-Si) were prepared at a constant current density of 30 mA/cm² for etching periods of 10, 20, 40 and 60 minutes. The ClAlPc material was prepared in laboratory from 20 g of phthalonitrile, 5 g of AlCl₂ which was refluxed in 100 ml of quinoline for 2 hr. The product was filtered and then the resulting precipitate was washed sequentially in toluene, carbon tetrachloride and acetone. The product was then dried at 70 The prepared ClAlPc Dve (0.1g) was mixed in 5ml (0.001M) of ethanol. The resultant mixture is used as a sensitizer of porous silicon substrate for which Doctor Blade technique was used. The prepared samples were characterized by UV - DRS and PL techniques. The prepared samples of

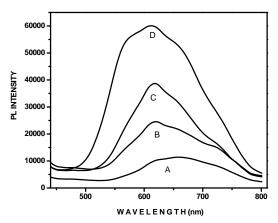


Figure 1-Photoluminescence spectra for the PS samples prepared at (30mA/cm, 48% HF) (A) 10 mins (B) 20 mins (C) 40mins (D) 60mins

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Ps/ClAlPc photoanode with different porosities were used to fabricate DSSCs.

3. RESULTS AND DISCUSSION

3.1. **Photoluminescence**

Photoluminescence (PL) emission spectra for all the above PS samples and ClAlPc/PS were recorded at room temperature spectroflurophotometer using USA). The PL spectra of PS prepared at constant current density of 30mA/cm² for 10, 20, 40 and 60 min shown in Fig.1 and PS/ClAlPc are shown in Fig.2. Initially the UV absorption measurements were carried out and they are in the range of 1.5 eV to 2.0 eV. The band gap of PS calculated by UV absorption and PL emission spectra for different etching parameters is given in Table 1 and the agreement is quite good. For the PS sample, the PL intensity increases with increasing etching time. It is observed that the band gap PS is slightly blue shifted with increase in etching time for constant current density. This shift in band gap (band gap widening) is because of quantum confinement due to reduction in the size of the Si nanocrystallite for increasing etching time [13]. And also the blue shift PL emissions of PS are slightly blue shifted with increase in etching time, which could be due to the decrease in nanocrystallites of silicon with increase in porosity of the samples [14].

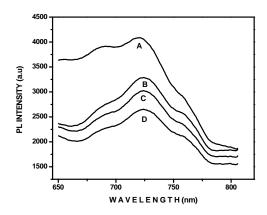


Figure 2- Photoluminescence spectra for the ClAlPc/PS samples prepared at (30mA/cm, 48% HF) (A) 10 mins (B) 20 mins (C) 40mins (D) 60 mins

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Samples prepared with		Band gap in eV			
electrolytic concentration	PS		ClAlPc/PS		
of 30mA/cm ²					
	PL	UV	PL	UV	
A (10 minutes)	1.81	1.805	1.5949	1.594	
B(20 minutes)	1.91	1.891	1.6464	1.691	
C (30 minutes)	2.01	1.981	1.7182	1.712	
D (40 minutes)	2.02	2.053	1.7646	1.776	

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Table 1- Bandgap values from PL and UV measurement for PS and ClAlPc/ PS samples

3.2. I-V Measurement:

Prepared solar cells (1 cm² size) were characterized by current - voltage (I–V) characteristics. Photocurrents and voltages were measured using a Keithley source meter 2400, with a 80 W halogen lamp and AM 1.5 G, and the light intensity was adjusted . Quality of the solar cell is determined by a parameter called solar cell efficiency that is simply defined by a ratio:

$$\eta = \frac{P_{\text{max}}}{P_I}, \quad (1)$$

where P_{max} is the maximum solar cell power and P_L is power of the incident light. So, solar cell efficiency and Pmax are associated by a linear dependence. At constant power of incident, light change in P_{max} reflects peculiarities in solar cell efficiency and quality of the cell as well. Maximum power created of solar cell can be simply found by measuring its I-V characteristic under external biasing as well as measuring current of illuminated solar cell without bias and voltage changing loadings [15].

Samples prepared with	PS/ClAlPc	
electrolytic concentration	48% of	
of 30mA/cm ²	HF	
A (10 minutes)	0.83	
B(20 minutes)	1.23	
C (30 minutes)	1.68	
D (40 minutes)	2.84	

Table 3- Conversion Efficiencies of the DSSCs prepared by ClAlPc / PS samples

We suggest that this remarkable increase in power occurs because of better absorbance of incident light and because of

the better collection of excited charge carrier, by dye molecules present in the porous silicon structure.

IJCSET – Volume 3, Issue 1 – January 2017.4. CONCLUSION

Nanostructured porous silicon (PS) samples were prepared at a current density of 30mA/cm² for etching periods 10, 20, 40 and Then these samples were 60 minutes. characterized using UV -DRS and PL emission technique. The band gaps are calculated and compared. The band gap slightly increases with increase in etching time. To study the effect of dye sensitizer, on these samples, the surface of these PS samples sensitized was with derivative of Chloroaluminum Pc (ClAlPc). The dependence of absorption and emission intensities on these samples indicate that ClAlPc /PS prepared at current density of 30mA/cm² for etching time of 60 min indicate that it is good absorber of radiations and can be used for solar cell application. The efficiency of the DSSC was 2.8%.

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